

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Matthew G. Goodman <i>et al.</i>
Application No.	:	10/775,522
Filed	:	February 10, 2004
For	:	TWO-STAGE LOAD FOR PROCESSING BOTH SIDES OF A WAFER
Examiner	:	Sylvia MacArthur
Group Art Unit	:	1763
Confirmation No.	:	1057

AMENDMENT UNDER 37 C.F.R. 1.111**Mail Stop Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is responsive to an Office Action mailed August 24, 2006. A response is timely filed within the three-month shortened statutory period by November 24, 2006.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.